

Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	10/826,018
				Filing Date	
				First Named Inventor	Chiwoe Wayne Lo
				Art Unit	2861 2881
				Examiner Name	Judy Nguyen Jack Berman
Sheet	1	of	2	Attorney Docket Number	6317P090D2

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.†	Document Number	Publication Date Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code* (if known)			
JP US US		US-6,593,584	07-15-2003	Krans et al.	
		US-6,369,385	04-09-2002	Murray et al.	
		US-6,465,783	10-15-2002	Nakasuji, Mamoru	
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FOREIGN PATENT DOCUMENTS					
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Examiner Signature	Jack Berman	Date Considered	9/28/2005
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Based on PTO/SB/08A (08-03) as modified by Blakey, Solokoff, Taylor & Zafman (wr) 08/11/2003.

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.†	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T*
JB		T.R. GROVES, et al., "Distributed, multiple variable shaped electron beam column for high throughput maskless lithography", J. Vac. Sci. Technol., B 16(6), Nov/Dec 2000, pp. 3168-3173	
JB		E. YIN, et al., "Electron optical column for a multicolumn, multibeam direct-write electron beam lithography system", J. Vac. Sci. Technol., B 18(6), Nov/Dec 2000, pp. 3126-3131	
JB		A. KHURSHEE, "Permanent magnet objective lenses for multicolumn electron-beam systems", Review of Scientific Instruments, Vol. 72, Number 4, April 2001, pp. 2106-2109	
JB		EIICHI GOTO et al., "MOL (moving objective lens) Formulation of deflective aberration free system", Optik, 48 (1977), No. 3, pp. 255-270	

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